

Notice of References Cited	Application/Control No. 10/603,288		Applicant(s)/Patent Under Reexamination ALBOU, PIERRE	
	Examiner Jacob Y Choi		Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,698,912	03-2004	Yang, Chiu-Ling	362/516
	B	US-6,543,923	04-2003	Tamai, Hiroyuki	362/521
	C	US-6,352,359	03-2002	Shie et al.	362/522
	D	US-6,340,239	01-2002	Godbillon et al.	362/521
	E	US-6,210,028	04-2001	Murakoshi et al.	362/538
	F	US-6,155,702	12-2000	Blusseau et al.	362/520
	G	US-5,169,224	12-1992	Segoshi et al.	362/539
	H	US-6,152,589	11-2000	Kawaguchi et al.	362/518
	I	US-3,266,016	08-1966	SHIEGERU MARUYAMA; et. al.	362/494
	J	US-5,014,173	05-1991	Lindae et al.	362/510
	K	US-6,416,210	07-2002	Uchida, Naoki	362/539
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.